

Notice of References Cited	Application/Control No. 10/595,684	Applicant(s)/Patent Under Reexamination HEFEL, ANDREAS	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	WO 97/26865	07-1997	PCT	Baichwal	-----
	O	KR 143767	07-1998	Korea, Republic	CHO H et al.	-----
	P					
	Q					
	R					
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NON-PATENT DOCUMENTS

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